

DO NOT ENTER: /J.S./

Expedited procedure  
Under 37 CFR 1.116

1374.46346X00

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: S. EGUCHI, et al.  
Serial No.: 10/588,959  
Filed: AUGUST 10, 2006  
For: MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE  
Group AU: 2891  
Examiner: Julia Slutsker  
Confirm. No: 4026

**AMENDMENT AFTER FINAL REJECTION**

**Mail Stop: AF – FEE**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

July 6, 2009

Sir:

In response to the Office Action mailed March 3, 2009, the period for response having been extended for one (1) month by the attached Petition for Extension of Time, please amend the above-identified application as listed in the following, and as set forth on the following pages:

AMENDMENTS TO THE CLAIMS; and

REMARKS are included following the amendments.